

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Nozomu SARUHASHI	
Application No.: 10/528,641	Art Unit: 3714
Confirmation No.: 4561	Examiner: B. Gebremichael
Filing or 371(c) Date: October 27, 2005	
Title: REMOTE EDUCATION SYSTEM, COURSE ATTENDANCE CHECK METHOD, AND COURSE ATTENDANCE CHECK PROGRAM	

INFORMATION DISCLOSURE STATEMENT COVER LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 CFR § 1.56, Applicant submits references, including references cited in any included Official Communication issued in a corresponding non-U.S. application, with the attached Form PTO/SB/08a.

Where available, Applicant has provided:

- 1) English language equivalents of the foreign language references cited in the included Official Communication or Applicant's Specification and has not provided the foreign language references;
- 2) English language abstracts of the provided foreign language references obtained from a corresponding foreign Patent Office; and
- 3) English machine translations of the provided Japanese references that were

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prepared by the Intellectual Property Digital Library of the Japanese Patent Office.

The statement is not a representation that all of the information cited is necessarily effective as prior art against the application.

Respectfully submitted,

Dated: February 11, 2008

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